

MS AF
Amendment filed with an RCE
Expedited Processing
Examining Group 2815
PATENT
3430-0131P

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S):	HWANG, Kwang-Jo	CONF.:	5562
SERIAL NO.:	09/648,111	GROUP:	2815
FILED:	August 25, 2000	EXAMINER:	A. R. Wilson
FOR:	METHOD OF PATTERNING A METAL LAYER IN A SEMICONDUCTOR DEVICE		

AMENDMENT FILED WITH A REQUEST FOR CONTINUED EXAMINATION

Box AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the final Office Action dated September 20, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application in this Amendment as a submission under 37 CFR §1.114(c), with respect to a Request for Continued Examination (RCE) filed on even date herewith.

This reply includes Amendments to the Claims and Remarks.